

Title (en)
SELF-ASSEMBLY OF CHIPS BY SUBSTRATE

Title (de)
SELBSTANORDNUNG VON CHIPS MIT HILFE EINES SUBSTRATS

Title (fr)
AUTO-ASSEMBLAGE DE PUCE SUR UN SUBSTRAT

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Application
EP 09731239 A 20090407

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Abstract (en)
[origin: WO2009124921A1] The invention relates to a method of forming, on the surface of a substrate (2), at least one hydrophilic attachment zone (12) for the purpose of self-assembling a component or a chip (3), in which a hydrophobic zone (20), which delimits said hydrophilic attachment zone, is produced.

IPC 8 full level
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H01L 2224/8385 (2013.01 - EP US); **H01L 2224/83894** (2013.01 - EP US); **H01L 2224/9202** (2013.01 - EP US);
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Citation (search report)
See references of WO 2009124921A1

Citation (examination)
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